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S/N 10/804,610

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KITAOKA, ET AL. Examiner: TU TU V. HO
 Serial No.: 10/804,610 Group Art Unit: 2818
 Filed: MARCH 18, 2004 Docket No.: 10873.1420US01
 Title: METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE
 AND SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on
 September 19, 2006.

By: 
 Name: Lisa A. Dorn

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop: AMENDMENT
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, Virginia 22313-1450

Dear Sir:

In response to the non-final Office Action mailed June 22, 2006, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the Listing of Claims that begins on page 2 of this paper.

Remarks begin on page 11 of this paper.

09/20/2006 TL0111 00000057 503478 10804610
 01 FC:1201 200.00 DA
 02 FC:1202 600.00 DA